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**CERTIFICATE OF MAILING**

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TECHNOLOGY CENTER 3700

PATENT  
CASE NO. 7103/30-1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: )  
Homayoun Talieh et al. )  
Serial No.: 08/853,323 ✓✓ )  
Filed: May 8, 1997 )  
For: LINEAR POLISHER AND )  
METHOD FOR )  
SEMICONDUCTOR WAFER )  
PLANARIZATION )

Examiner: G. Nguyen

Group Art Unit: 3723

**RESPONSE AND AMENDMENT**

Assistant Commissioner for Patents  
Washington, D.C. 20231

Dear Sir:

In response to the Office Action dated September 21, 1999 please enter the following amendment and consider the following remarks: